

Supporting Information

for

Exploring the fabrication and transfer mechanism of metallic nanostructures on carbon nanomembranes via focused electron beam induced processing

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Additional experimental data

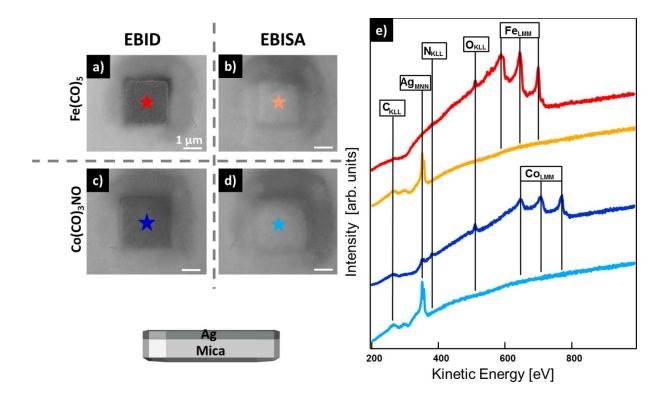


Figure S1: Results of FEBIP experiments followed by autocatalytic growth on Ag(111)/mica. All structures were written with $E_{\text{beam}} = 15 \text{ kV}$ and $I_{\text{beam}} = 3 \text{ nA}$. (a) SEM image of a 2 × 2 μ m² deposit fabricated via EBID + AG with Fe(CO)₅ (4.7 C/cm² and $t_{AG} = 2 \text{ h } 26 \text{ min}$). (b) SEM image of a 2 × 2 μ m² deposit fabricated via EBISA + AG with Fe(CO)₅ (10.1 C/cm² and $t_{AG} = 2 \text{ h } 41 \text{ min}$). (c) SEM image of a 2 × 2 μ m² deposit fabricated via EBID + AG with Co(CO)₃NO (4.7 C/cm² and $t_{AG} = 2 \text{ h } 24 \text{ min}$). (d) SEM image of a 2 × 2 μ m² deposit fabricated via EBISA + AG with Co(CO)₃NO (10.1 C/cm² and $t_{AG} = 2 \text{ h } 47 \text{ min}$). (e) Local AE spectra recorded at the positions indicated with the correspondingly colored stars.

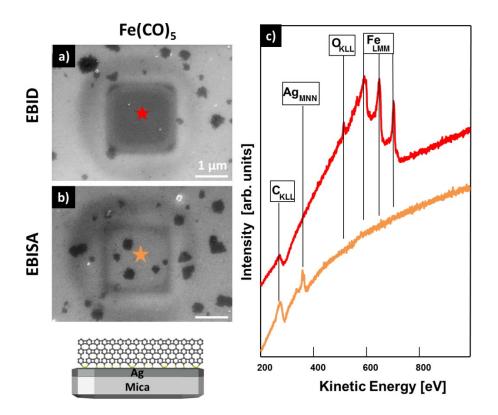


Figure S2: Results of FEBIP experiments followed by autocatalytic growth on a CNM on Ag(111)/mica. All structures were written with $E_{beam} = 15 \text{ kV}$ and $I_{beam} = 3 \text{ nA}$. (a) SEM image of a $2 \times 2 \mu m^2$ deposit fabricated via EBID + AG with Fe(CO)₅ (7.8 C/cm² and $t_{AG} = 3 \text{ h}$ 38 min). (b) SEM image of a $2 \times 2 \mu m^2$ deposit fabricated via EBISA + AG with Fe(CO)₅ (7.8 C/cm² and $t_{AG} = 4 \text{ h}$ 2 min). (c) Local AE spectra recorded at the positions indicated with the correspondingly colored stars.

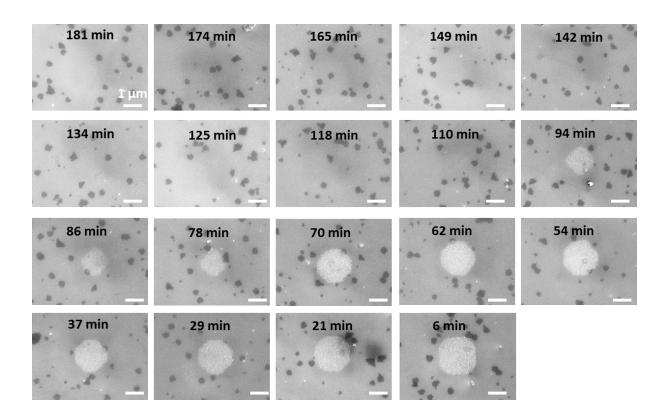


Figure S3: Results of time-dependent EBISA experiments followed by autocatalytic growth on a TPT SAM on Ag(111)/mica. All structures were written with $E_{\text{beam}} = 15 \text{ kV}$, $I_{\text{beam}} = 3 \text{ nA}$, and the same $t_{\text{AG}} = 3 \text{ h } 29 \text{ min.}$ SEM images of $2 \times 2 \text{ µm}^2$ deposits fabricated via EBISA + AG with Fe(CO)₅ (electron dose: 1.01 C/cm²). The waiting time between electron irradiation and precursor dosage is indicated for each structure.

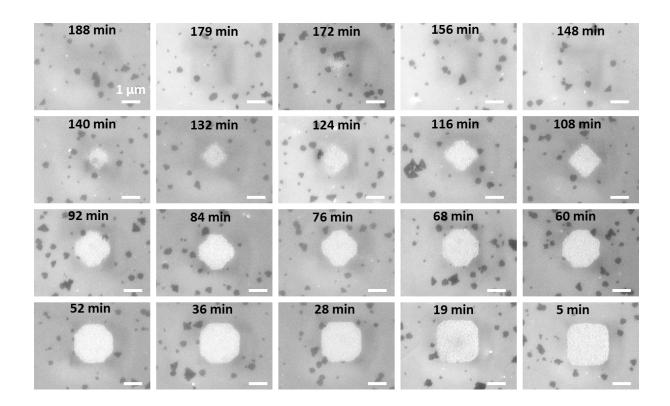


Figure S4: Results of time-dependent EBISA experiments followed by autocatalytic growth on a TPT SAM on Ag(111)/mica. All structures were written with $E_{\text{beam}} = 15 \text{ kV}$, $I_{\text{beam}} = 3 \text{ nA}$, and the same $t_{\text{AG}} = 3 \text{ h } 29 \text{ min}$; SEM images of $2 \times 2 \text{ µm}^2$ deposits fabricated via EBISA + AG with Fe(CO)₅ (electron dose: 3.12 C/cm^2). The waiting time between electron irradiation and precursor dosage is indicated for each structure.

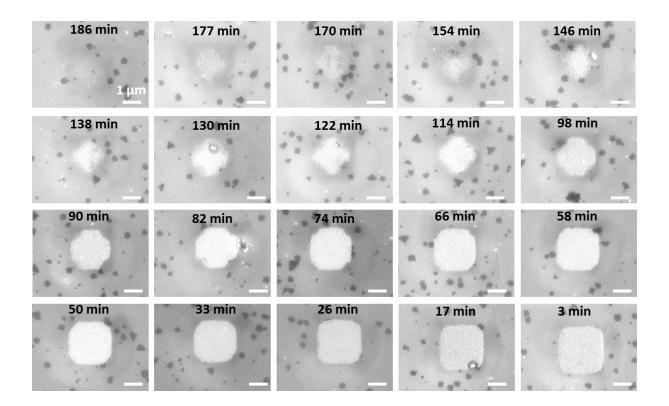


Figure S5: Results of time-dependent EBISA experiments followed by autocatalytic growth on a TPT SAM on Ag(111)/mica. All structures were written with $E_{\text{beam}} = 15 \text{ kV}$, $I_{\text{beam}} = 3 \text{ nA}$, and the same $t_{\text{AG}} = 3 \text{ h} 29 \text{ min}$. SEM images of $2 \times 2 \text{ µm}^2$ deposits fabricated via EBISA + AG with Fe(CO)₅ (electron dose: 6.08 C/cm²). The waiting time between electron irradiation and precursor dosage is indicated for each structure.

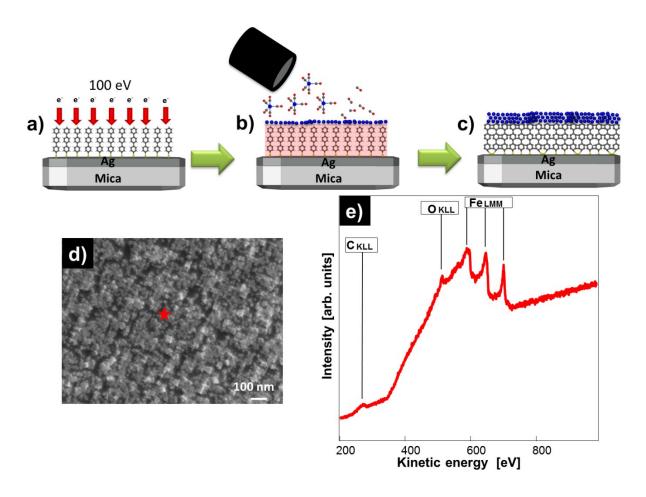


Figure S6: EBISA-like process with low-energy electrons. (a) Irradiation of a TPT SAM on Ag(111)/mica (100 eV; 120 mC/cm²) by a flood gun. (b) Dosage of the Fe(CO)₅ precursor for 4 h. The active species in the SAM are indicated by the red rectangle. (c) Cross-linked CNM with Fe nanocrystals on top. (d) SEM image of the cross-linked CNM with Fe nanocrystals on top. (e) Local AE spectrum recorded at the position indicated by the colored star.

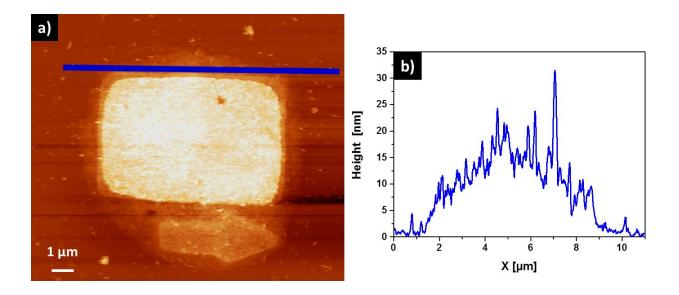


Figure S7: (a) AFM image of the Fe structure shown in Figure 4c of the main manuscript. (b) Height profile of the bright circular feature around the Fe structure

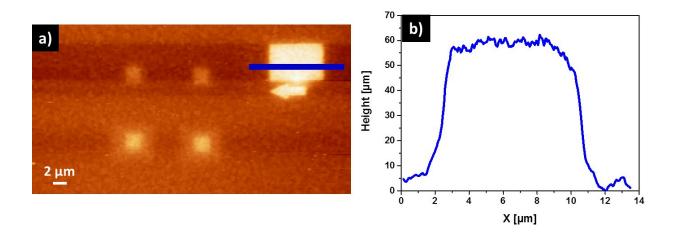


Figure S8: (a) AFM image of five different cobalt oxide structures before the transfer process. (b) Height profile of the large marker structure